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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

New York, New York

Tatsufumi KUSUDA et al.

Date: November 13, 2003

Serial No.: 10/645,067

Group Art Unit: Not Yet Assigned

Filed: August 21, 2003

Examiner: Not Yet Assigned

For: LIGHT IRRADIATION TYPE THERMAL PROCESSING APPARATUS

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Respectfully submitted,

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November 13, 2003
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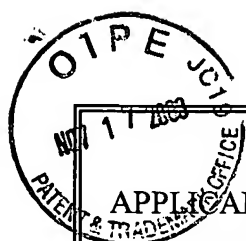
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Enclosures



APPLICANT'S ART CITATION

(Use several sheets if necessary)

Application 10/645,067

OFGS File No. P/1250-255

Applicant Tatsufumi KUSUDA et al.

Filing Date August 21, 2003

Group Art Unit

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	Filing Date If Appropriate
	US- 4,571,486	02/1986	Arai et al.			02/18/1986
	US- 4,649,261	03/1987	Sheets			02/07/1985
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FOREIGN PATENT DOCUMENTS

	Document Number	Date MM-YYYY	Country	Class	Sub-class	Translation	
						Yes	No
	2002-110579	04-2002	Japan				X
	2002-110580	04-2002	Japan				X
	2001-237195	08-2001	Japan				X
	57-162340	10-1982	Japan				X
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OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	English translation of Abstract for Japanese Patent Application Laid Open No. 2002-110579
	English translation of Abstract for Japanese Patent Application Laid Open No. 2002-110580
	English translation of Abstract for Japanese Patent Application Laid Open No. 2001-237195
	English translation of Abstract for Japanese Patent Application Laid Open No. 57-162340
	English translation of Abstract for Japanese Patent Application Laid Open No. 63-166219
	Japanese Patent Application Laid Open No. 59-169125 which corresponds to U.S. Patent
	No. 4,571,486 (as listed above)
	Japanese Patent Application Laid Open No. 60-258928 which corresponds to U.S. Patent
	No. 4,649,261 (as listed above)

Examiner

Date Considered

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